

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of :
Elias BITAR et al. : Confirmation No. 4104
U.S. Patent Application No. 10/577,063 : Group Art Unit: 2624
Filed: April 24, 2006 : Examiner: Stephen R. KOZIOL
For: METHOD FOR DETERMINING OPTIMAL CHAMFER MASK COEFFICIENTS FOR DISTANCE TRANSFORM

AMENDMENT AND RESPONSE UNDER 37 CFR § 1.111

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated September 11, 2008, a reply being due Feb. 11, 2009 with a two month extension of time, please amend the above-identified application as follows:

Amendments to the Claims – page 2

Remarks/Arguments – page 7